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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jin-Seok LEE, et al.

Application No.: 10/811,896

Group Art Unit: 1765

Confirmation No.: 1334

Filed: March 30, 2004

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For: ETCHING APPARATUS AND METHOD

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement mailed February 13, 2006, Applicants elect claims 1-20 of Group I, without traverse.

Respectfully submitted,

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